

<b>APPLICANT'S ART CITATION</b> (Use several sheets if necessary)		Application 10/534,309		OFGS File No. P/1757-63			
		Applicant <b>Vahe S. YACOUBIAN et al.</b>					
		Filing Date October 11, 2005		Group Art Unit 3766			
<b>U.S. PATENT DOCUMENTS</b> (not submitted for applications filed after 6/30/03)							
Examiner Initial	Document Number	Date MM-YYYY	Name	Class	Sub-class	Filing Date If Appropriate	
	US-5,489,294	02-1996	McVenes et al.				
	<del>US-6,231,314</del>	<del>05-2001</del>	<del>Lowe et al.</del>				
	US-						
	US-						
	US-						
	US-						
<b>FOREIGN PATENT DOCUMENTS</b>							
	Document Number	Date MM-YYYY	Country	Class	Sub-class	Translation	
						Yes	No
	2001-87397	04-2001	Japan			English Language Abstract	
	7-222807	08-1995	Japan			corresponding to U.S. Patent No. 5,489,294	
	3-112566	05-1991	Japan			English Language Abstract	
	WO 93/09840	05-1993	PCT				
<b>OTHER DOCUMENTS</b> (Including Author, Title, Date, Pertinent Pages, Etc.)							
		<del>Japanese Office Action</del>					
		<del>Canadian Office Action</del>					
Examiner /Kennedy Schaetzle/		Date Considered 03/10/2009					
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